



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Fabrice LETERTRE et al.

Confirmation No.: 4652

Application No.: 10/678,127

Group Art Unit: 2811

Filing Date: October 6, 2003

Examiner:

For: WAFER AND METHOD OF PRODUCING
A SUBSTRATE BY TRANSFER OF A
LAYER THAT INCLUDES FOREIGN
SPECIES

Attorney Docket No.: 4717-7400

REQUEST FOR CORRECTION OF FILING RECEIPT

Office of Initial Patent Examination
Customer Service Center
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A Filing Receipt for the above-identified application has been received and the following corrections are respectfully requested.

In the title of the application, please correct the spelling of "foreigh" to
-- foreign --

A copy of the Filing Receipt with the requested change noted thereon is attached.

No fee is believed to be due for this submission. Should any fees be required, however, please charge such fees to Winston & Strawn LLP Deposit Account No. 50-1814.

Respectfully submitted,

Feb. 25, 2004
Date

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202-371-5771



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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/678,127	10/06/2003	2811	860	4717-7400	4	25	3

28765
 WINSTON & STRAWN
 PATENT DEPARTMENT
 1400 L STREET, N.W.
 WASHINGTON, DC 20005-3502



CONFIRMATION NO. 4652
FILING RECEIPT



OC000000011587884

Date Mailed: 12/30/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Fabrice Letertre, Grenoble, FRANCE;
 Yves Mathieu Levaillant, Croles, FRANCE;
 Eric Jalaguier, Saint Martin D'uriage, FRANCE;

Domestic Priority data as claimed by applicant

Foreign Applications

FRANCE 0212405 10/07/2002

If Required, Foreign Filing License Granted: 12/29/2003

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

Title

Wafer and method of producing a substrate by transfer of a layer that includes foreign species

foreign